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H1D

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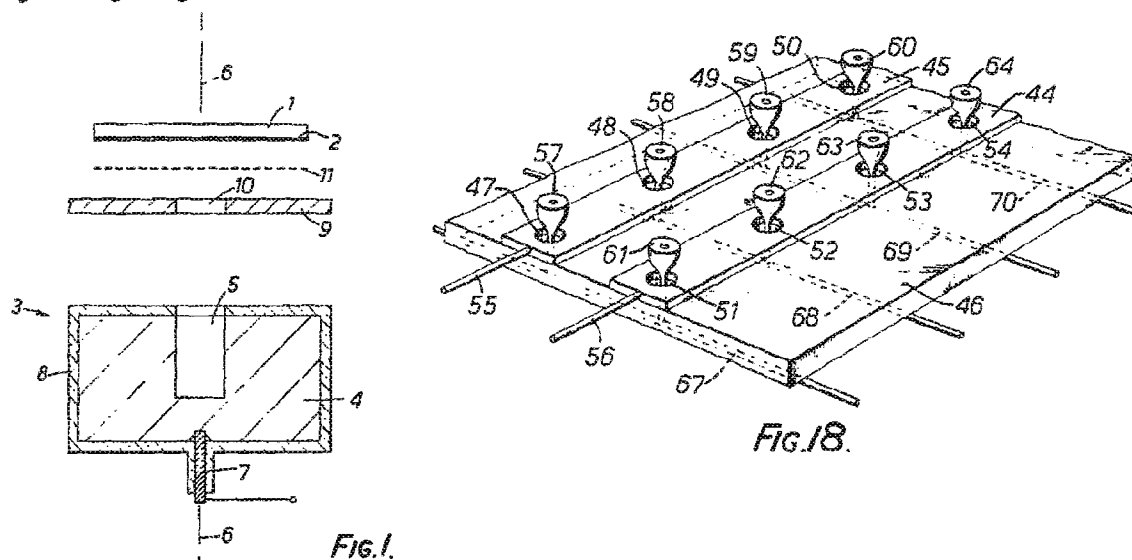
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(54) Apparatus for forming electron beams

(57) An envelope containing a gas filling includes a cathode 3 having, except for one or more portions or (as shown) notes 5 formed in a front surface thereof, all surfaces which would otherwise be exposed to the gas filling covered with an electrically insulating material, such as glass, and an anode 9 such that upon application of a suitably high voltage between the cathode and anode an electron beam is formed directed away from the front surface of the cathode. A grid 11, alternatively located in hole 5, modulates the beam; the anode may be located behind the front surface of the cathode, and still form a beam in front of the front surface. Fig. 18 shows such an arrangement in which the anodes and cathodes form an addressable crossed matrix. The front cathode surface may be oblique with respect to the hole or holes therein (Fig. 20) or may be curved (Fig. 21) to form a plurality of beams focussed to a point. The apparatus may comprise a CRT display when provided with a phosphor layer 2 or may be used for electron beam welding. The described beam arrangement can form the cathode of the thyatron (Figs. 22-24) or can be used to heat a separate thermionic cathode or can be used to ionise the gas filling locally in front of a conventionally heated thyatron cathode. Materials of electrodes and gas filling are given.



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The drawing(s) originally filed was/were informal and the print here reproduced is taken from a later filed formal copy.

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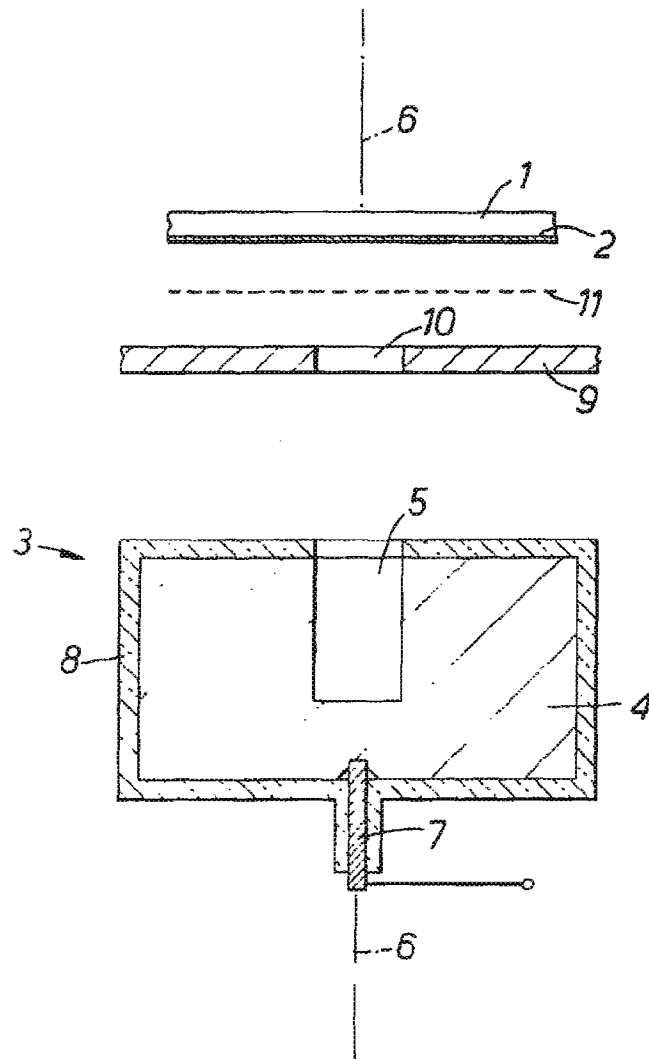


FIG. 1.

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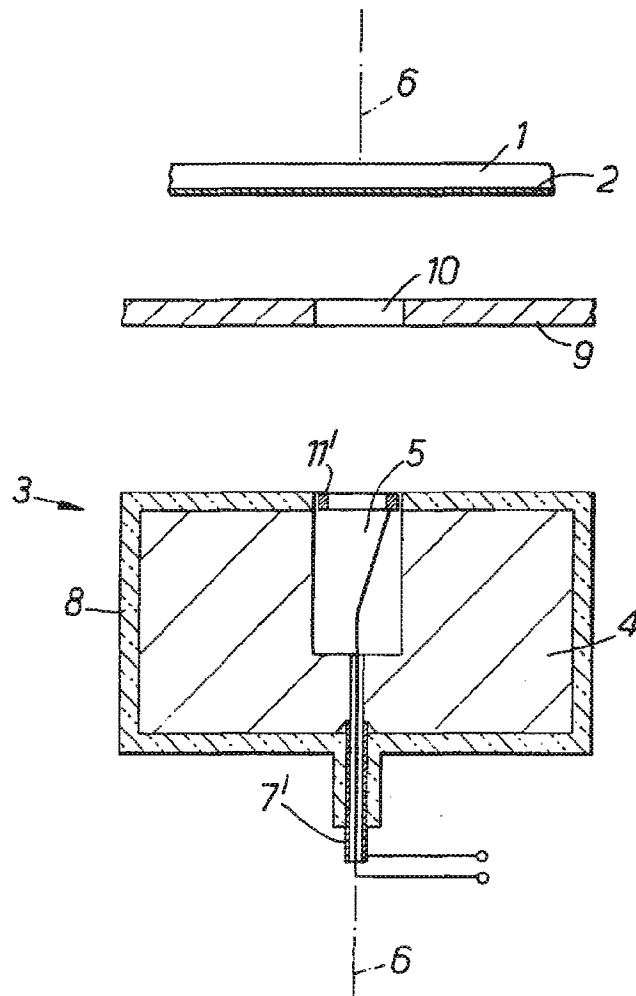


FIG. 2.

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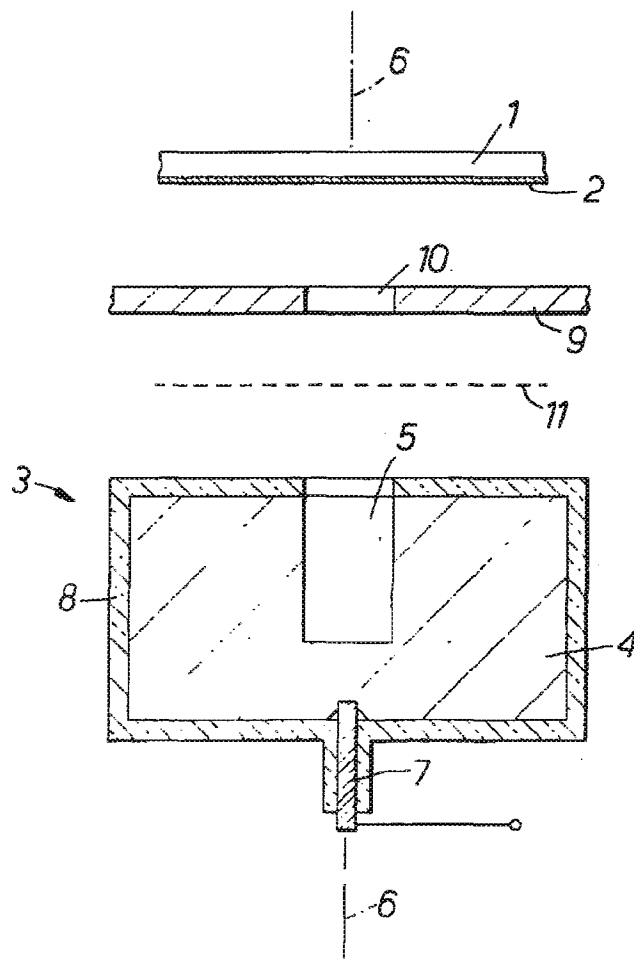


FIG. 3.

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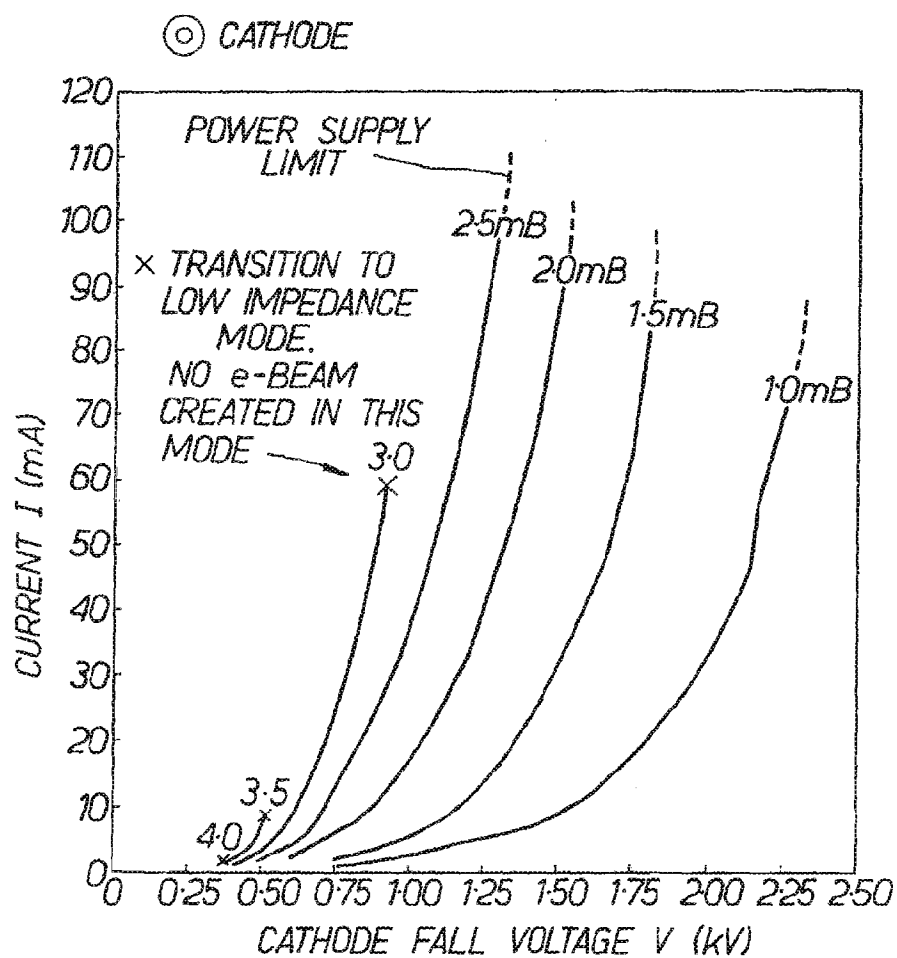


FIG. 4.

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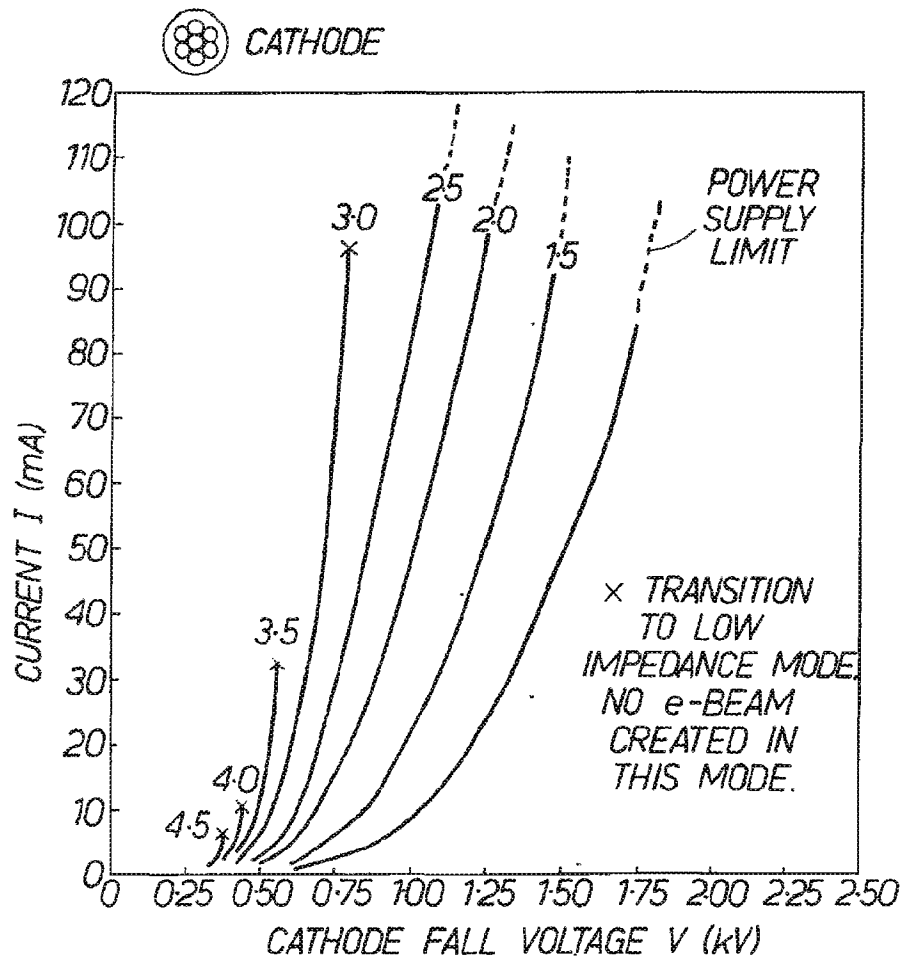
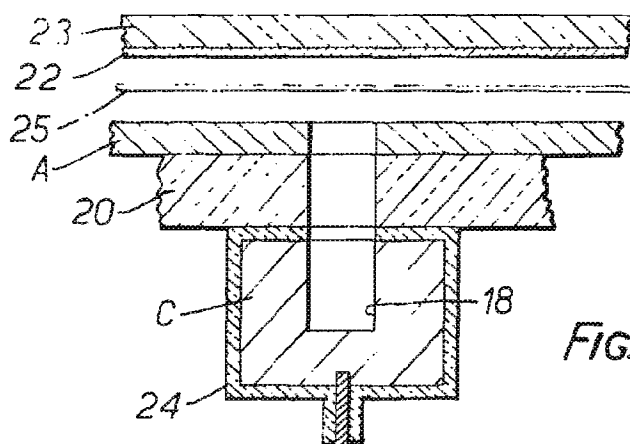
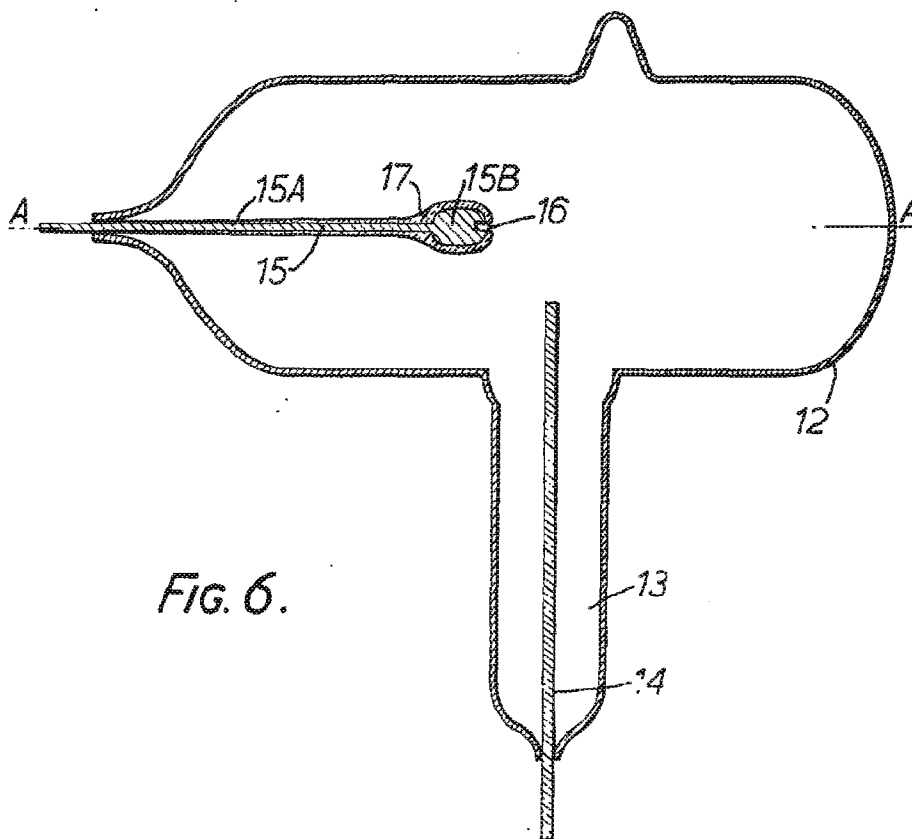


FIG. 5.

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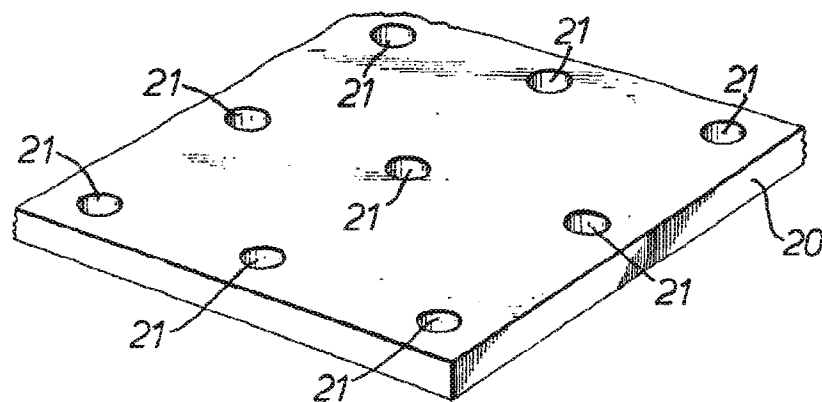


FIG. 8.

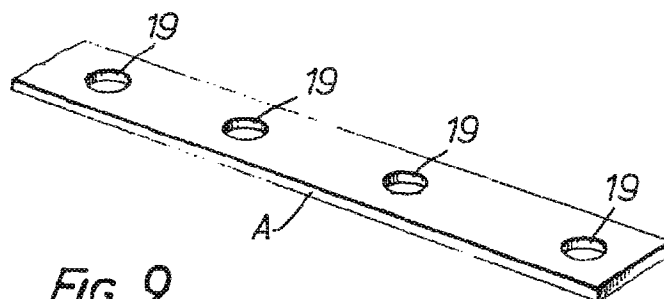


FIG. 9.

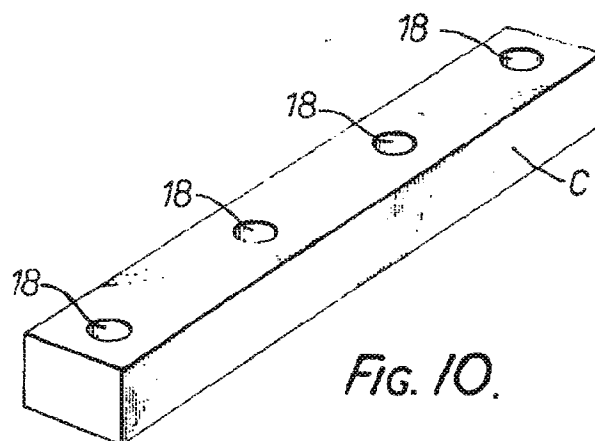


FIG. 10.

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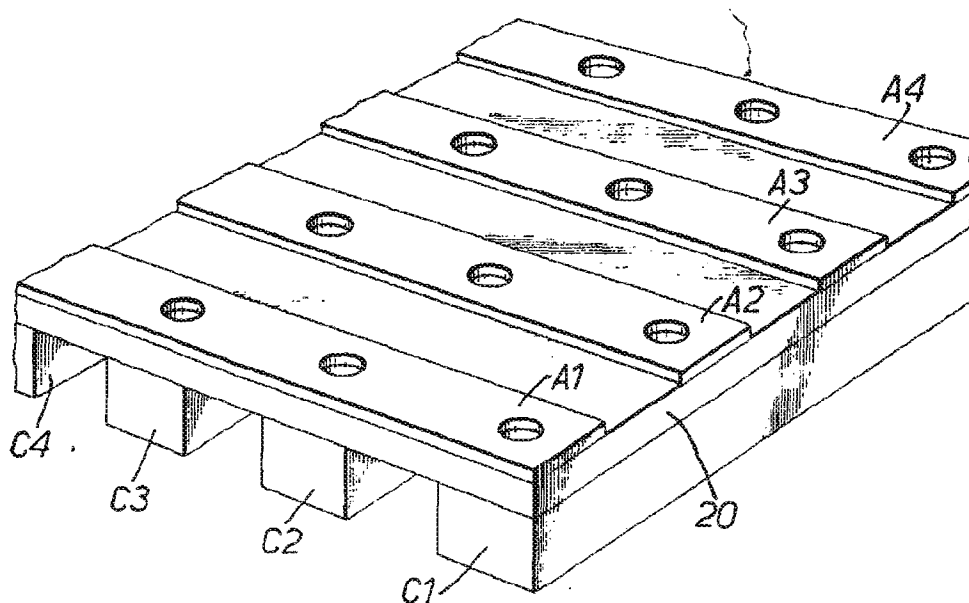


FIG. 11.

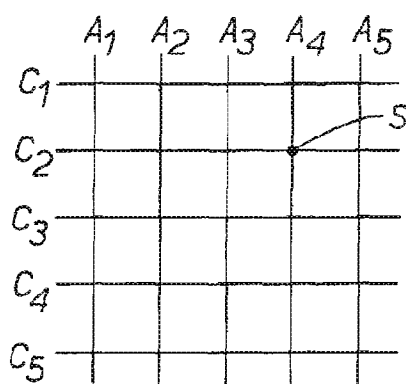
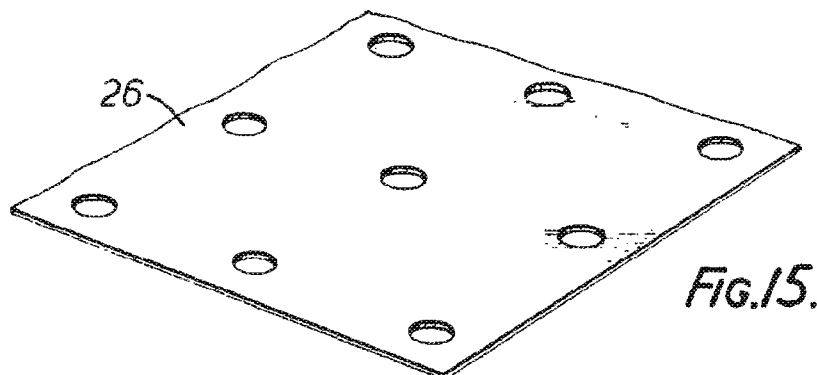
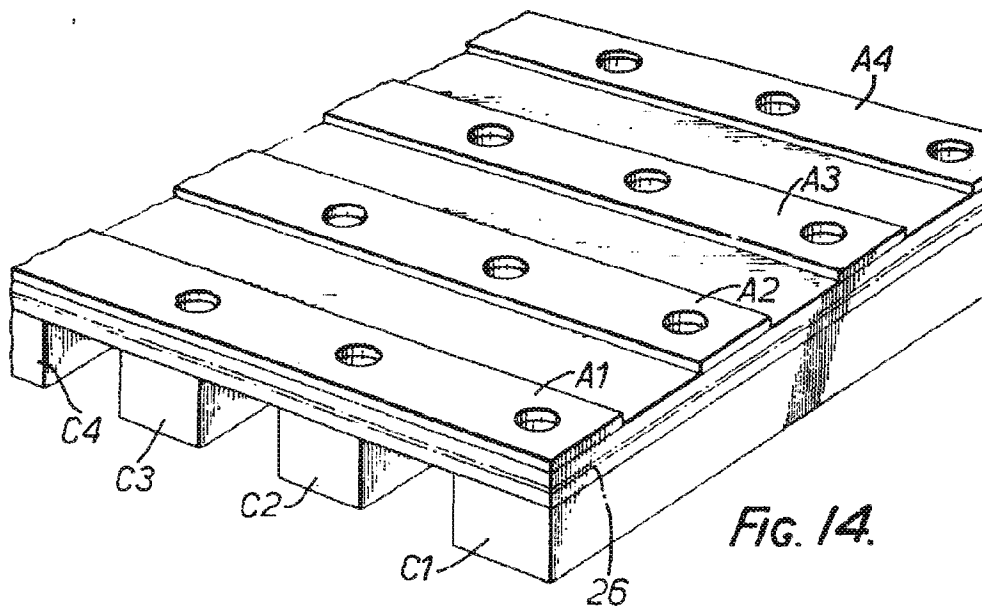
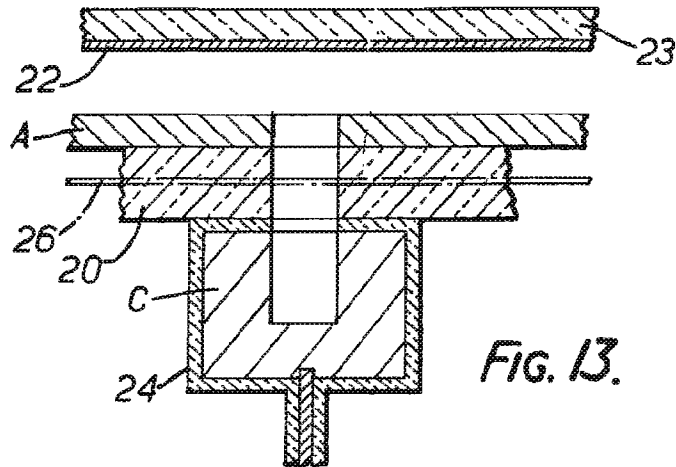


FIG. 12.

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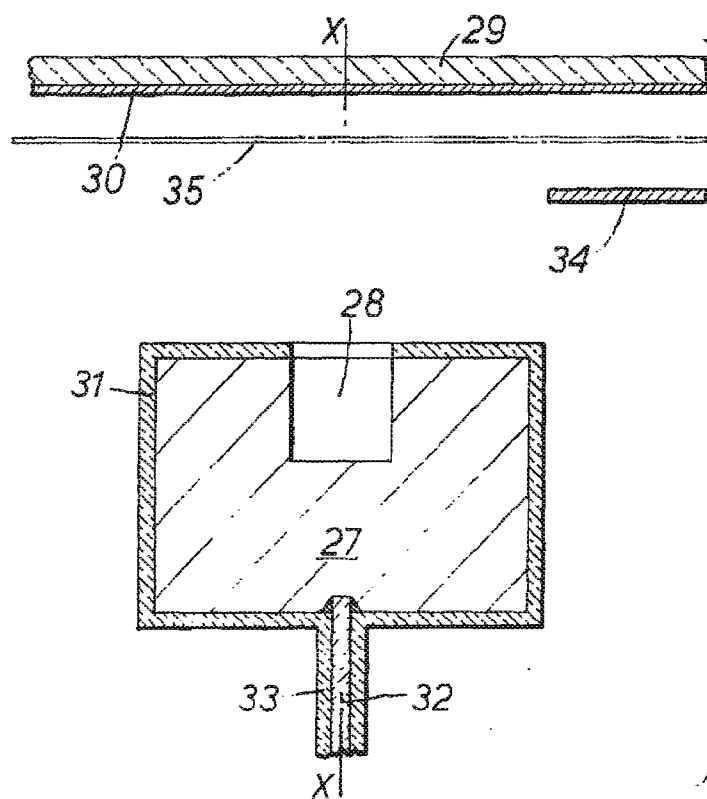


FIG. 16.

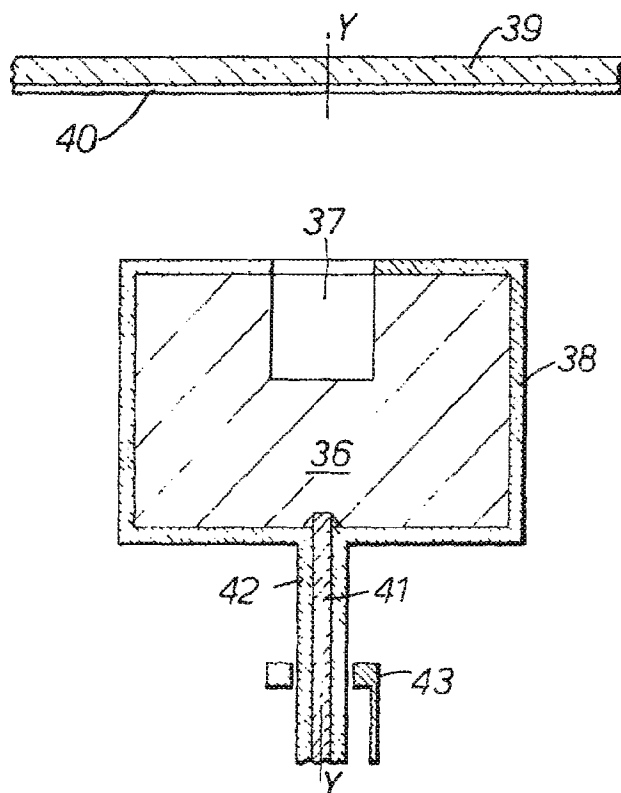


FIG. 17.

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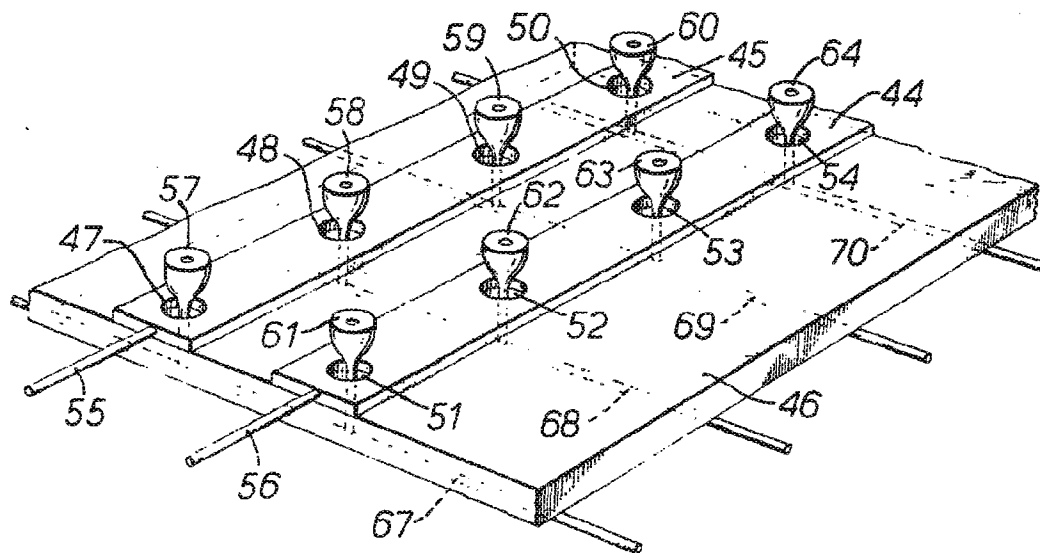


Fig. 18.

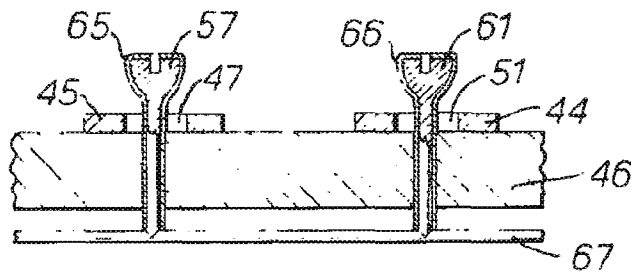


Fig. 19.

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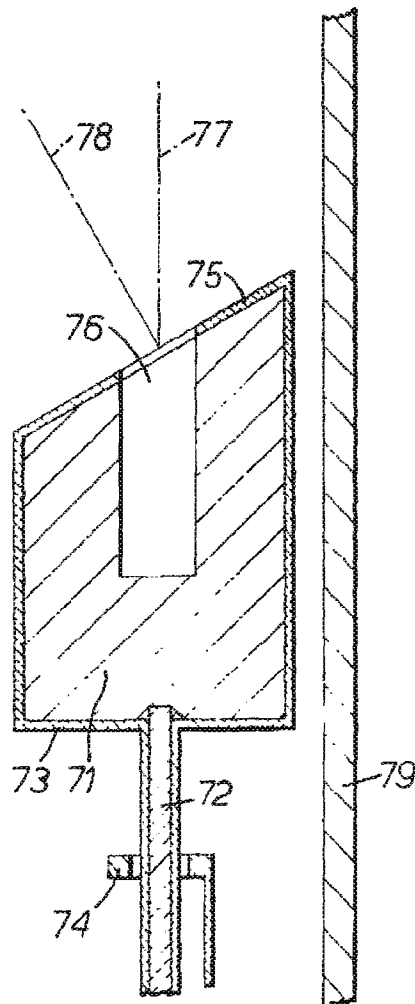


Fig. 20.

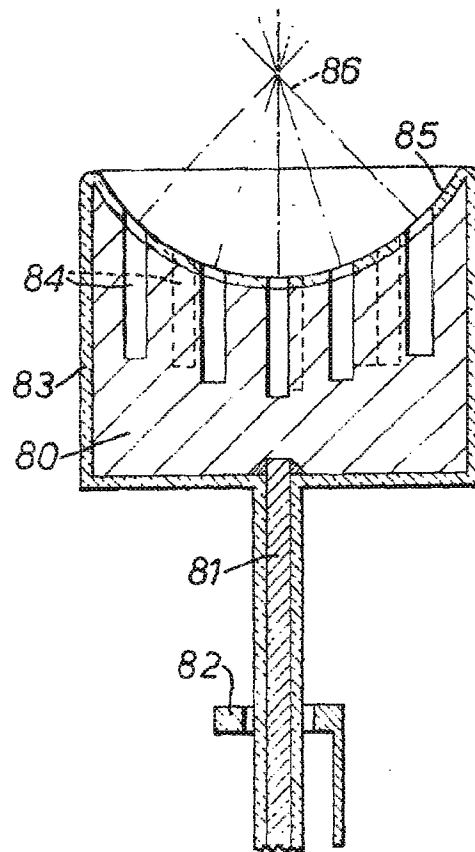


Fig. 21.

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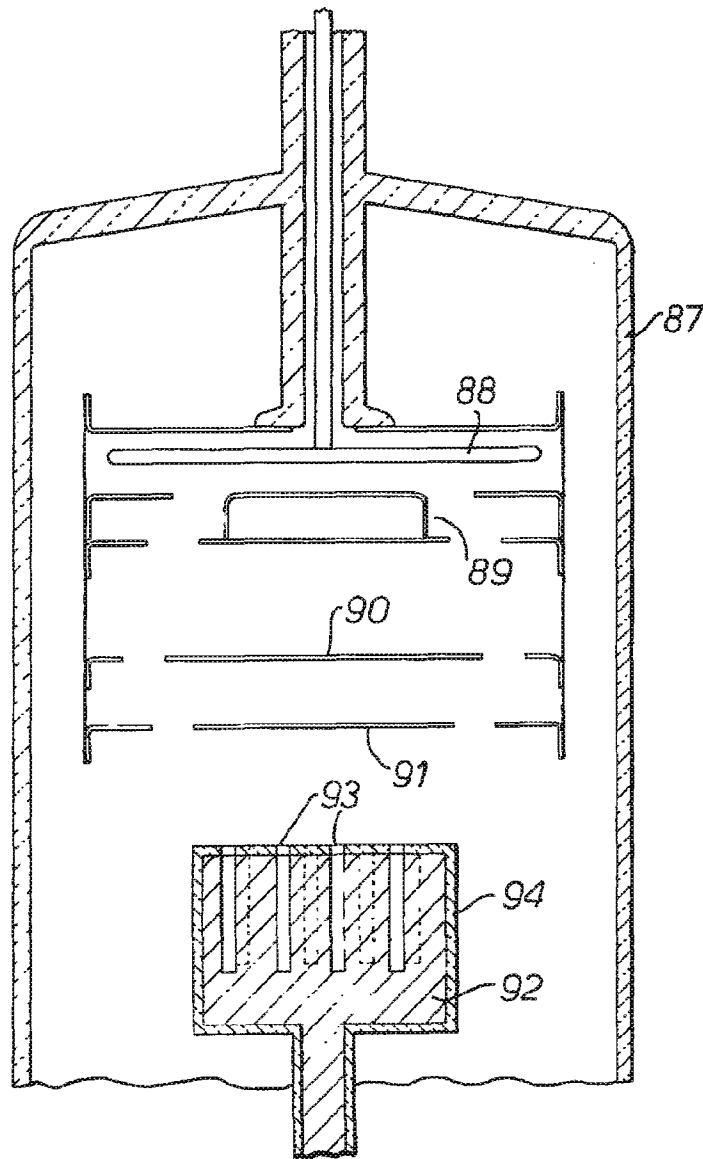


FIG. 22.

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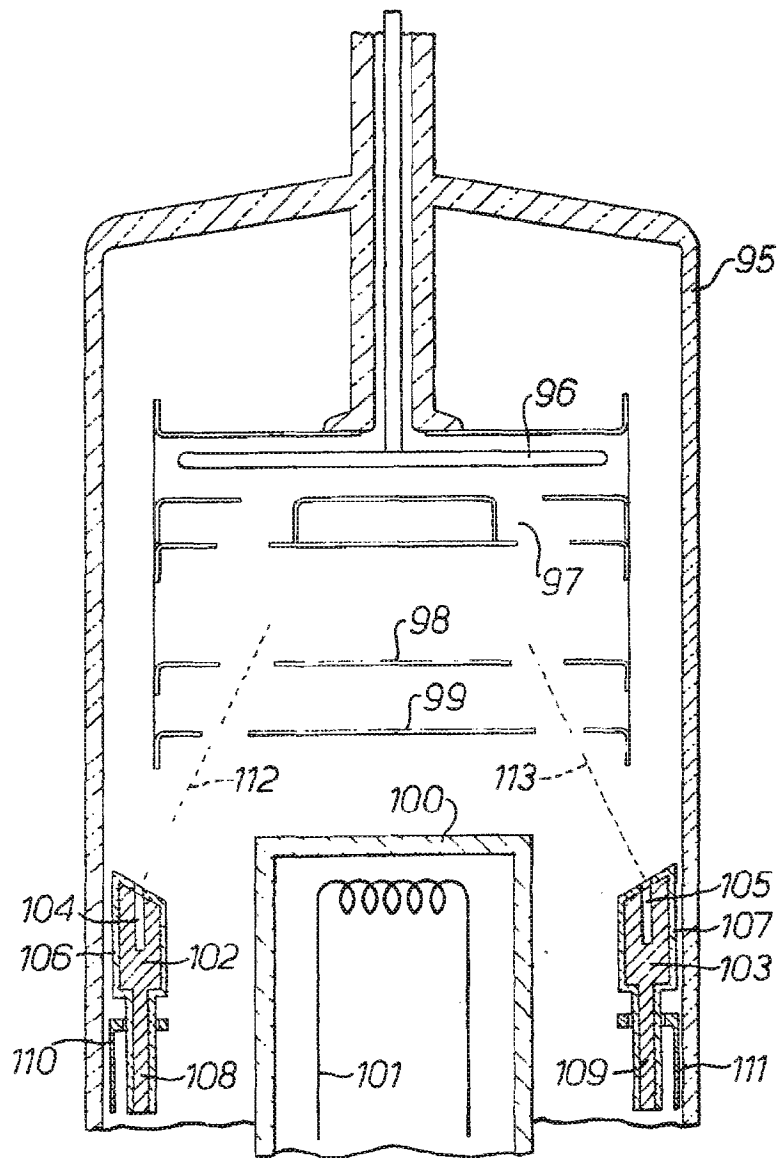


FIG. 23.

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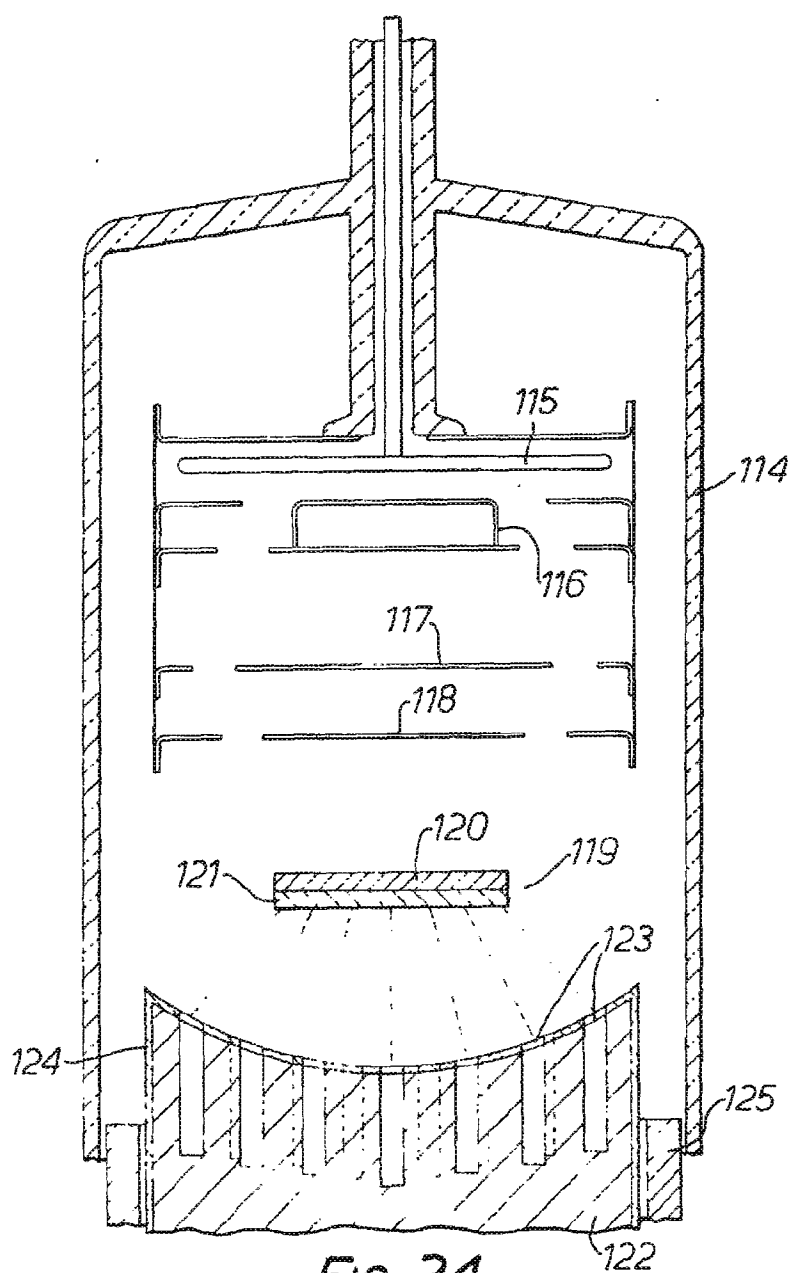


FIG. 24.

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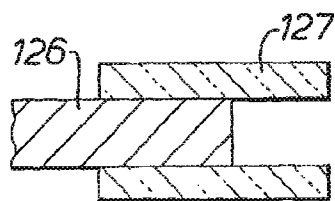


FIG. 25.

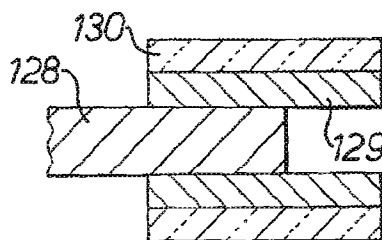


FIG. 26.

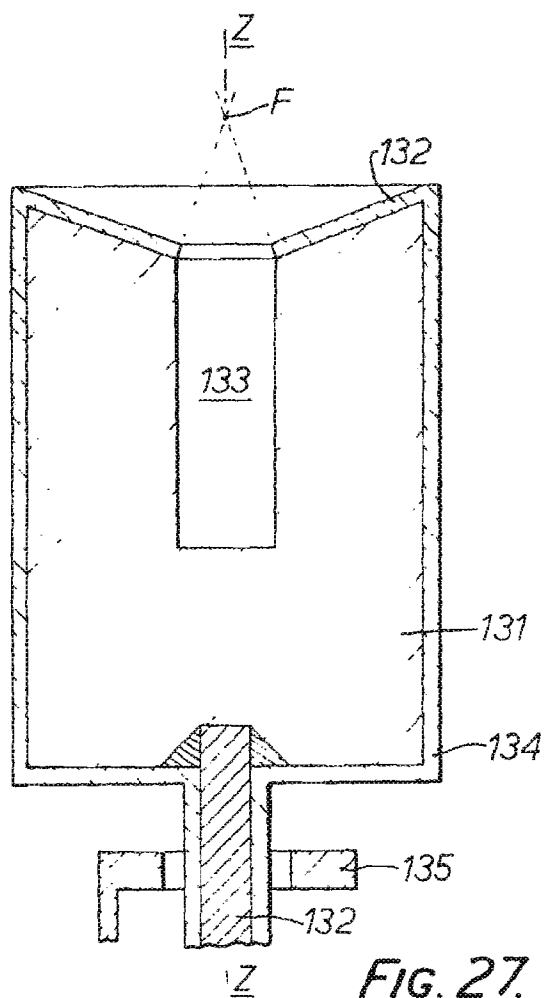


FIG. 27.

SPECIFICATION

Apparatus for forming electron beams

5 This invention relates to apparatus for forming electron beams, and to apparatus requiring the formation of electron beams, such as, for example, display devices and thyatrons.

The present invention seeks to provide improved apparatus for forming electron beams.

10 According to a first aspect of the invention there is provided apparatus for forming an electron beam comprising, within an envelope, an anode member; a cathode member of electrically conductive material; and a gas filling, and wherein, except for part of a front surface of said cathode member, at least substantially the whole of the surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material; the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member an electron beam is formed extensive in a direction away from said part of said front surface.

According to a second aspect of the invention there is provided apparatus for forming an electron beam comprising, within an envelope, an anode member; a cathode member of electrically conductive material and having a hole in a front surface thereof; and a gas filling, and wherein, except within said hole, at least substantially the whole of the surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member an electron beam is formed extensive in a direction away from said hole.

45 According to a third aspect of the invention, the anode member is located in front of the front surface of the cathode member.

Preferably a control grid electrode is included through which operation the electron beam passes, enabling the intensity or energy of the electron beam, to be modulated.

Preferably the apparatus includes a plurality of elongate cathode members arranged in a grid formation, and a plurality of elongate anode members arranged in a grid formation with said grid of anode members superimposed over said grid of cathode members, but spaced therefrom, with said anode members in crossing relationship with said cathode members to form a matrix, each of said cathode members having a series of holes entering into its surface facing said grid of anode members and each of said anode members having a series of holes passing therethrough, with each hole in an anode member aligned

70 with a hole in a different one of the cathode members, and all surfaces of said cathode members, except for surfaces within said holes in said cathode members, which would otherwise be exposed to said gas filling are isolated therefrom by electrically insulating material, and the whole arrangement being such that by applying a high potential between one of said anode members and one of said cathode members an electron beam is formed at the crossing point of said last-mentioned two members, said electron beam being extensive in the space between the mouth of the hole in the cathode member at said crossing point and said anode member, said beam being arranged to penetrate through the corresponding hole in said addressed anode member.

It will be appreciated that by suitably addressing selected ones of said anode and cathode members an electron beam may be created which, by varying the selection of anode and cathode members addressed may be caused to be animated.

Preferably, insulating material is interposed between said grid of cathode members and said grid of anode members, which insulating material has passages therethrough aligned with said holes in said cathode and anode members whereby to permit communication between one cathode hole and the appropriate anode hole but impede communication between that cathode hole and any other anode hole.

Preferably, said last-mentioned interposed insulating material is provided in the form of a slab having holes extending between its major surfaces and forming the said passages.

A control grid electrode may be located on the side of the grid of anode members other than that on which the grid of cathode members is located, or alternatively it may be located between the grid of cathode members and the grid of anode members, and where insulating material is interposed between the cathode and anode grids the control grid electrode may be embedded in the interposed insulating material.

The anode member may be to one side of the axis of the electron beam formed in operation, such that said beam passes by said anode. It has been found by the inventors that the electron beam may be formed along the axis of the hole even though the anode member is displaced to the side of its path.

120 According to a fourth aspect of the invention the anode member is located behind said front surface of the cathode member, and again in this configuration the electron beam may be formed along the axis of the hole, rather than along the shortest path between the anode and cathode members.

Preferably the anode member is co-axial with the cathode member. Preferably a grid is included through which in operation the electron beam passes, enabling it to be modulated

in intensity or energy, although of course, this may be achieved by varying the high voltage between the anode and cathode members.

Preferably there are included a plurality of
5 elongate anode members, each having apertures therein; and a plurality of stemmed cathode members, each having a hole in the front surface thereof and arranged such that its stem extends through one of said apertures, such that each anode member is lo-
10 cated behind the front surfaces of cathode members whose stems pass through apertures in said anode member, whereby by applying a high potential between an anode member and
15 one of the cathode members extending through an aperture therein an electron beam is formed extensive in a direction away from the hole in said one of the cathode members.

As previously described where the grid of
20 anode members are located in front of the grid of cathode members, by addressing selected cathode and anode members an electron beam may be formed in a desired location, or number of such beams formed simul-
25 taneously if cathode members may be individually addressed.

Preferably a cathode member extending through an aperture in one anode member is electrically connected to another cathode
30 member extending through an aperture in another anode member and also preferably a connector connecting two cathode members is spaced from the anode members by electrically insulating material.

Preferably where the apparatus in accordance with this invention is included in a display device a phosphor layer is included and is arranged so that when an electron
35 beam is formed it impinges upon a spot upon said layer whereby to excite the same and preferably said envelope has a portion formed as a faceplate on the interior of which said phosphor layer is provided.

According to a feature of this invention a
45 video signal reproducing apparatus includes apparatus as described above.

According to a feature of the invention in its third aspect a cathode ray tube apparatus comprises a plurality of elongate cathode
50 members arranged in a grid formation, a plurality of elongate anode members arranged in a grid formation with said grid of anode members superimposed over said grid of cathode members, but space therefrom, with said
55 anode members in crossing relationship with said cathode members to form a matrix, each of said cathode members having a plurality of holes entering into its surface facing said grid of anode members and each of said anode
60 members having a plurality of holes passing therethrough, with each hole in an anode member aligned with a hole in a different one of the cathode members and, superimposed over said grid of anode members on the side
65 thereof remote from said grid of cathode

members, a phosphor screen, the two grids being enclosed within an envelope having a gas filling from which all surfaces of said cathode members, except for surfaces within
70 said holes in said cathode members, which would otherwise be exposed to said gas filling are isolated therefrom by electrically insulating material, and the whole arrangement being such that by applying a high potential be-
75 tween one of said anode members and one of said cathode members an electron beam is formed at the crossing point of said last-mentioned two members, said electron beam being extensive in the space between the
80 mouth of the hole in the cathode member at said crossing point and said anode member, said beam penetrating through the corresponding hole in said addressed anode member to impinge upon a spot upon said phosphor whereby to excite the same.

According to a fifth aspect of the invention the longitudinal axis of said hole is oblique to the normal of said front surface, and the electron beam is formed normal to said front
90 surface of said hole. The inventors discovered that, when the hole is arranged with its longitudinal axis inclined to the normal of the front surface, an electron beam is not formed parallel to the aforesaid axis as might be expected
95 but is in fact, surprisingly, formed in a direction normal to the front surface. Where in this specification the term "normal" is used, it should be taken to include "substantially normal". Apparatus utilising this principle may
100 be useful where, for example, space is restricted and it would not be possible to employ a device in which the hole is arranged normal to the surface of the cathode. Also manufacture of the device is facilitated since
105 only the direction of the front surface need be accurately machined.

Such apparatus may include a plurality of holes in said front surface, at least one of said holes having its longitudinal axis oblique to the normal of said front surface at that hole,
110 such that upon the application of said suitably high voltage electron beams are formed extensive normal to said front surface at and in a direction away from respective holes. Since the configuration of the front surface was found by the inventors to determine the direction of electron beams produced, a desired pattern of electron beams or concentration of electron beams may be achieved without
115 costly machining. For example, if a plurality of beams which are mutually parallel are required the holes need not be drilled in precise relationship to each other, as might have been thought, as only the front surface need be
125 made flat. Of course the front surface can be curved if more complex patterns are required, and because of leniency in the disposition of the holes the cathode member may be more conveniently shaped for a desired application.

According to a sixth aspect of the invention

there is provided apparatus for forming electron beams comprising, within an envelope, an anode member; a cathode member of electrically conductive material having a front surface which is curved; and a gas filling, and wherein, except for a plurality of discrete parts of the said front surface, at least substantially the whole of the surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member electron beams are formed extensive normal to said front surface at and in a direction away from respective parts.

It is preferred that, where there are a plurality of electron beams formed, the front surface is curved such that they are focussed or concentrated at a point or small region. This is a particularly useful configuration providing apparatus suitable for inclusion in an electron beam welder, or as a point source of soft X-rays or incandescent black body radiation.

According to a seventh aspect of this invention there is included a layer of phosphor material on a viewable screen arranged such that upon the application of said suitably high voltage the electron beam impinges upon said phosphor layer and so excites the same.

According to a feature of the seventh aspect of this invention a display apparatus comprises, within an envelope, a layer of phosphor material on a viewable screen; remote from said phosphor layer, a metallic cathode member having a hole formed in a front surface thereof; between said cathode member and said phosphor layer, an apertured anode electrode; and a gas filling, and wherein, except within said hole, at least substantially the whole of the surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member an electron beam is formed extensive in the space between the mouth of the hole in said cathode member and said anode member, and is arranged to penetrate through an aperture in said anode member to impinge upon said phosphor layer and so excite the same.

Preferably said envelope has a portion formed as a faceplate upon the inner surface of which said phosphor layer is provided.

The apparatus may include a modulating grid provided to affect the strength or intensity of the electron beam impinging upon said phosphor layer.

Said modulating grid may be a perforated grid or gauze provided either between said anode member and said phosphor layer or

between said anode member and said cathode member. In other embodiments of the invention said modulating grid comprises a ring grid provided within the mouth of said hole in said cathode member. In this last mentioned case preferably an electrical connection for said grid is taken out, in insulated fashion through said cathode member in a direction away from said anode member, i.e. through the base of said cathode member.

Where, as is preferable, electrical connection to said cathode member is provided for by means of an electrical connector connected to the base of said cathode member, said last mentioned connector is preferably in the form of a hollow cylinder with an electrical connector for said grid passing, in insulated fashion, therethrough.

There may be provided a single hole in said cathode member with a corresponding single aperture in said anode member but alternatively a plurality of holes may be provided in said cathode member with a corresponding plurality of holes in said anode member.

Where a plurality of holes and apertures are provided these may be in ring formation, with or without a central disposed hole and aperture.

According to a feature of the second aspect of the invention thyatron apparatus comprises, within an envelope, an anode member; a cathode member of electrically conductive material and having a hole in a front surface thereof; and a gas filling, and wherein, except within said hole, at least substantially the whole of the surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member an electron beam is formed extensive in a direction away from said hole.

Preferably said cathode member has a plurality of holes in the front surface thereof, such that upon application of a suitably high voltage electron beams are formed extensive in a direction away from respective holes, and it is preferred that said front surface is curved, such that some focussing of the electron beams to a point may be obtained. Also it is preferred, where the front surface is curved, that at least one of said holes has its longitudinal axis oblique to the normal of said front surface at that hole. The cathode member may form the cathode of a thyatron, or advantageously thermionic material may be included and arranged such that when an electron beam or beams are formed they heat the same. This heating may be direct or indirect. For example, a substrate carrying the thermionic material may be exposed to the electron beam or beams and heat transmitted to the thermionic material by conduction.

Alternatively, when the electron beam is formed, it may be arranged to ionize the gas filling in a localised region, and so improve operating characteristics of a thyatron, and advantageously the longitudinal axis of the hole is oblique to the normal of said front surface at the hole, enabling the cathode member to be accommodated in a restricted space. Of course, more than one such cathode member may be employed.

According to an eighth aspect of the invention said front surface is shaped to focus said electron beam. Thus even where only one hole is employed the electron beam may be focussed. Each point of the surface around the mouth of the hole and at its edge may be thought of as directing components of the electron beam normal to the surface at respective points. Thus by providing the surface with a certain configuration, for example a convex shape or advantageously a frusto-conical configuration, with the hole being centrally located, a desired degree of focussing may be obtained. For example, the electron beam may be focussed to a point or it could be focussed merely enough to aid in further collimation of the electron beam.

Generally the, or each hole in a cathode member is blind, and preferably of circular cross-section.

Preferably said insulating material insulating surfaces of said cathode member, or plurality of cathode members, from said gas filling is glass, but where said cathode member, or members, is of an anodisable metal, such as aluminium or titanium, the insulating material may be anodisation.

Preferably said cathode and anode members are of Kovar (R.T.M.) but other metals or alloys may be used, such as aluminium, copper or tungsten, or of molybdenum, tantalum or other refractory metals for high current use.

Generally said envelope is of glass or quartz.

Preferably the side wall and base surfaces of each hole is entirely free of a covering of electrically insulating material.

A number of gases, or mixture of gases, may be used for said gas filling including helium and/or argon and/or deuterium and/or neon. The hole size and voltages applied are related to the type of gas employed. Typically, hole sizes for argon are 0.2 to 0.1 of the size of those for helium, giving the possibility of more compact devices.

Preferably said gas filling is at a pressure of between 0.5 and 2.5 mB.

Normally the higher voltage utilised to address the anode and cathode members is from 1 to 5 kV and preferably between 1 and 2.5 kV.

The invention is further described by way of example with reference to the accompanying drawings in which:

Figure 1 is a schematic cross-section of one simple electronic display device in accordance with the present invention;

Figure 2 and 3 illustrate modifications of the device illustrated in Fig. 1, like references being used for like parts in Figs. 1 to 3;

Figure 4 and 5 are explanatory graphs;

Figure 6 shows, in longitudinal cross-section, another example of an electron beam device in accordance with the present invention;

Figure 7 is a schematic cross-section through a flat screen cathode ray display device in accordance with the present invention;

Figure 8 illustrates in perspective part of the insulating slab 20 of Fig. 7;

Figure 9 illustrates, part broken away, one elongate anode member A used in the device of Fig. 7;

Figure 10 illustrates, part broken away, one elongate cathode member C utilised in Fig. 7;

Figure 11 is a perspective view, part broken away, of an assembly of cathode and anode members with the slab of insulating material shown in Fig. 8 sandwiched therebetween;

Figure 12 is a schematic diagram illustrating the operation of the device illustrated in Figs. 7 to 11;

Figure 13 is a schematic cross-section through another flat screen cathode ray device in accordance with the present invention;

Figure 14 illustrates in perspective part of the device of Fig. 13;

Figure 15 illustrates in perspective part of the device of Fig. 13; with like references being used for like parts;

Figure 16 is a schematic cross-section of a display device in accordance with the invention;

Figure 17 is a schematic cross-section of another display device in accordance with the invention;

Figure 18 is a perspective view, part broken away, and

Figure 19 a cross-sectional view, of yet another device in accordance with the invention;

Figure 20 shows a longitudinal section of a further apparatus in accordance with the invention;

Figure 21 is a longitudinal section of another apparatus in accordance with the invention;

Figure 22 illustrates a thyatron in accordance with the invention;

Figure 23 illustrates another thyatron in accordance with the invention;

Figure 24 shows yet another thyatron in accordance with the invention;

Figure 25 illustrates a cathode member in accordance with the invention;

Figure 26 shows another cathode member; and

Figure 27 illustrates another device in ac-

cordance with the invention.

Referring to Fig. 1, a device comprises a quartz envelope of which only one portion 1 is shown. The envelope portion 1 is provided as a faceplate having on its interior a layer 2 of phosphor material similar to that used in conventional cathode ray display tubes. Associated with the phosphor layer 2 is a transparent metal layer (not shown but somewhat akin to the transparent metal layer forming part of the screen of a conventional cathode ray tube) between the layer 2 and the faceplate. The faceplate formed by the portion 1 of the envelope of the device is transparent.

Within the envelope and at the end thereof opposite to the faceplate portion 1, is a cathode member 3 which comprises a block 4 of Kovar having a blind hole 5 formed therein, in this case by drilling coaxially with the axis of cylindrical symmetry 6 of the device. The open mouth of the hole 5 faces the phosphor layer 2. In the base of the block 4, adjacent the blind end of the hole 5, a connecting pin 7 is inserted so as to enable electrical connection to be made to the Kovar block 4.

All of the external surfaces of the Kovar cathode block 4, with the exception of the wall and base surfaces of the blind hole 5, which would otherwise be exposed to a gas filling within the envelope of the device are covered by electrically isolating material represented at 8. In this example, the insulating material 8 is glass.

Between the cathode 3 and the phosphor layer 2 is an anode electrode 9 which has a circular hole 10 passing therethrough. Circular hole 10 is coaxially aligned with the blind hole 5 within the Kovar block 4.

It will be noted that the cathode 3 is devoid of a heater as such, or any electron emissive cathode material, such as barium.

The envelope of the tube is filled with helium at a pressure of between 0.2 and 10 mB.

As so far described the device is in its simplest form. For the moment it will be assumed that grid 11, shown between the anode electrode 9 and the phosphor layer 2, is absent.

Provided that the dimensions of the cathode and anode holes 5 and 10 and the spacing of the anode 9 to the cathode 3 is suitably chosen, a type of electrical discharge will be established between the anode 9 and the cathode 3 which results in the formation of an electron beam along the axis 6 of the coaxially aligned anode and cathode holes when a potential difference in the range of from several hundred volts to several thousand volts is established between the anode 9 and the block 4 of cathode 3. Within limits, the electron beam acquires energy approximately equal to the anode to cathode potential difference and so extends into the region beyond the anode hole 10 to impinge, finally, upon

the phosphor layer 2 thus exciting it.

Thus, in operation, whenever a potential as aforesaid is established between anode 9 and block 4 of cathode 3, the resulting electron beam causes a spot to appear on the screen 1 due to excitation of the phosphor layer 2. Whilst the aforementioned dimensions and spacing may be arrived at empirically, in the particular example illustrated in Fig. 1, the cathode and anode holes were of 5 mm diameter. With a gas filling of helium at a pressure of 2 mB and a potential difference between anode 9 and cathode 3 of approximately 1.5 kV, the device was found to operate with a spacing between the plane of the anode 9 and the surface of the phosphor layer 2 of up to a few centimetres, and a spacing between the anode 9 and the cathode 3 of at least 3 mm. With the above-mentioned potential difference of 1.5 kV the current drawn from the cathode, was of the order of 15 mA.

Reverting to the aforementioned grid 11—by introducing a control grid, modulation of the intensity or energy of the electron beam arriving at the surface of the phosphor layer 2 may be achieved by varying a potential applied to the grid 11. Alternatively or additionally varying the potential between the anode 9 and the cathode 3 will produce or enhance a modulation effect but, of course, it is much less convenient to apply modulation at high potential.

Referring to Fig. 2, the essential difference between the device shown in Fig. 2 and the device shown in Fig. 1 resides in the fact that a mesh grid such as 11 in Fig. 1 is not provided between the anode 9 and the phosphor layer 2. Instead, a ring grid 11' is provided within the mouth of the blind hole 5 in the Kovar block 4. Electrical connection is made to the ring grid 11' by means of a connector passing out through the base of the Kovar block 4. In fact, instead of a pin 7 making contact with the block 4 the contact, here referenced 7', is cylindrical with the connecting lead for the grid 11' passing coaxially therethrough in insulated fashion. Although not shown in Fig. 2, insulating material would be provided to support the connecting lead for the grid 11 within the cylindrical connector 7'.

Referring to Fig. 3, in this case, compared to Fig. 1, the position of the grid 11 is changed. Instead of providing this between anode 9 and the phosphor layer 2 it is provided between the anode 9 and the cathode 3. In some cases this may be preferred since a relatively lower voltage is required compared to that required with the grid in the position shown in Fig. 1.

The graph of Fig. 4 shows the relationship between beam current I and cathode fall voltage V (i.e. the voltage applied between anode and cathode) for different gas filling pressures,

for a device as described above having cathode and anode holes of 5 mm in diameter.

In any of the embodiments described above with reference to Figs. 1, 2 and 3, instead of

- 5 a single cathode hole and a single anode hole
a plurality of blind holes may be provided in
the Kovar block 4 with each cathode hole
being coaxially aligned with a corresponding
hole passing through the anode member 9.
10 Typically in such a case, the holes will be
arranged in a ring formation, with or without
cathode and anode holes on-centre. The effect
achieved using a plurality of cathode and
anode holes in a simple device as illustrated
15 in Figs. 1 to 3, is that the areas of excitation
thus created in the phosphor layer 2 tend to
merge to produce a larger illuminated spot (or
other prescribed pattern as determined by the
pattern of holes on the faceplate 1) than
20 would otherwise be the case.

The graph of Fig. 5 shows parameters for this last-mentioned case corresponding to those shown in the graph of Fig. 4 for this embodiment shown in Fig. 1.

- 25 One application for a device as described
above is in large area displays such as those
sometimes found in public places in order to
impart information, e.g. in airport terminals or
sports areas. By arranging devices such as
30 those described above in rows and columns
and addressing individual devices appropriately,
letters and words—and even graphics—may be produced.

- Referring to Fig. 6, another device in accordance with the invention includes a glass
35 envelope 12 which is of generally circular
cross-section and has a transversely extending
side-arm 13 about mid-way along its length.
An anode member 14 extends through the
40 end wall of the side-arm 13 and into the main
part of the volume enclosed by the envelope
12.

- A cathode member 15 passes through an
end wall of the envelope 12. It has a stem
45 portion 15A and an enlarged end 15B with a
blind hole 16 of circular cross-section in its
front surface. All of the surfaces of the cathode
member 15 contained within the envelope 12,
except for the side wall and base
50 surfaces of the hole 16, are coated with a
layer of glass 17. The envelope 12 contains
helium at a pressure of 2 mB.

- In operation, a potential difference of about
1 kV is applied across the anode and cathode
55 members 14 and 15 and an electron beam is
formed along the axis A-A of the hole 16.

The envelope 12 has a length of about 7
cm and a diameter of about 3.5 cm.

- The anode and cathode members 14 and
60 15 are separated by approximately 1 cm in
the axial direction and 0.5 cm in the
transverse direction. The diameter of the hole
16 is 5 mm, with a depth (i.e. axial length) of
3 mm.

- 65 Referring to Figs. 7 to 11 a display device

comprises a plurality of elongate cathode
members C1 to C4 arranged parallel to one
another to form a grid. Each cathode member,
as shown in Fig. 10, comprises a bar of Kovar
70 having at regular intervals along its length
blind holes 18. The holes 18 extend into the
same planar surface of the cathode member.
Each cathode member is provided with an
electrical connector (not shown) by means of
75 which it may be individually addressed.

- Superimposed above the grid of cathode
members is a grid of parallel elongate anode
members A1 to A5 each of which consists of
a bar of Kovar having a series of holes 19
80 passing therethrough from one planar face to
its opposite planar face as illustrated in Fig. 9.
The pitch of the holes 19 in an anode member
corresponds to the spacing between the
cathode members in the cathode grid and the
85 spacing of the anode members in the anode
grid corresponds to the pitch of the cathode
holes 18 in a cathode member so that each
cathode hole 18 is aligned with an anode hole
19 at the crossing point of the anode and
90 cathode conductors in which those particular
holes appear.

- Sandwiched between the grid of cathode
members and the grid of anode members is a
slab 20 of glass which has rows and columns
95 of holes 21 therein extending from one major
planar face to its opposite major planar face,
as illustrated in Fig. 8. The rows and columns
of holes are spaced such that when the slab is
sandwiched between the grid of cathode
members and the grid of anode members, as
100 shown in Fig. 11, each aligned cathode and
anode hole at the crossing point of an anode
and cathode member is also aligned with a
hole in the slab of insulating material 20.
105 Thus, the holes 21 in the insulating slab 20
permit communication between appropriate
ones of the cathode and anode holes 18 and
19 but impede communication between each
cathode hole and other than the anode holes
with which it is directly aligned. Thus the
110 tendency for so-called "long path" discharges
to take place is reduced.

- Superimposed over the grid of anode members
is a phosphor screen comprising of a
115 layer of phosphor material 22 on the inside of
part of an enclosing envelope which is formed
as a faceplate 23. Associated with the layer
22 of phosphor material is a transparent layer
of conductive material (somewhat akin to the
transparent metal layer of the phosphor screen
120 of a conventional cathode ray tube device)
between the phosphor layer 22 and the faceplate
23. The envelope in this case is of glass
and encloses the anode and cathode members
125 together, of course, with the interposed slab
of insulating material 20.

- The envelope has a gas filling of helium
and, as illustrated only in Fig. 7, each cathode
member C is entirely covered with an electrically
130 isolating layer 24 of glass, except within

the holes 18. Thus, save for the wall and base surfaces of the holes 18 all surfaces of the cathode members which would otherwise be exposed to the helium gas filling are isolated therefrom. In fact, save for the interior surfaces of the holes 18 as aforesaid, all surfaces at cathode potential are so isolated from the gas filling. In this particular case the wall and base surfaces of the holes 18 are entirely free from glass. In this particular example the cathode and anode holes 18 and 21 are of circular cross-section with a diameter of 5 mm. The helium gas filling is at a pressure of 2 mB. The distance separating the grid of cathode members from the grid of anode members (i.e. the thickness of the slab 20) is a few millimetres whilst the distance separating the grid of anode members from the phosphor layer 22 is in the region of 0.5 to 2 cm.

If now, and referring particularly to Fig. 12, a 1.5 kV potential difference is established between cathode member C2 and anode member A4 then an electron beam will be formed in the region of the crossing point of members C2 and A4 which beam extends from out of the mouth of the cathode hole 18 at the crossing point through the corresponding hole in the insulating slab 20 to penetrate through the corresponding anode hole 19 in anode members A4 and impinge upon the phosphor screen to form a spot as represented at S in Fig. 12. By addressing different combinations of anode members and cathode members corresponding spots may be caused to appear on the screen at any of the crossing points and by suitably changing the combination of crossing points selected an animated display may be achieved.

No mention has so far been made of grid 25 shown in Fig. 7 as located between the grid of anode members A and the phosphor layer 22. The purpose of this grid, if provided, is to modulate the intensity or energy of the electron beams arriving at the phosphor.

Alternatively, with or without the grid 25, the overall intensity or energy of the electrons beams may be modulated or adjusted by appropriate alterations to the anode to cathode discharge current as determined by the voltage applied between the cathode and anode members.

In another embodiment a grid 26 is embedded in the slab 20, as shown in Figs. 13 and 14, and may comprise a gauze or as metal plate having holes which correspond to the anode and cathode holes, as illustrated in Figs. 15.

It will be noted particularly the absence of any form of conventional electron gun. No cathode heaters are employed in the device illustrated, the cathodes being cold cathodes, and no cathode material such as barium is employed.

With reference to Fig. 16, another embodi-

ment of the invention includes a cathode member 27 of Kovar having a hole 28 of about 5 mm diameter in its front surface and being enclosed in a glass envelope 29 which also contains helium gas at a pressure of about 2 mB and has a layer of phosphor on its inner surface to form a screen 30. The surfaces of the cathode member 27, except the side wall and base of the hole 28, are covered in a glass layer 31, which electrically insulates the cathode member 27 from the helium gas filling. Electrical connection to the cathode member 27 is made via a pin 32 which is sheathed with a layer 33 of glass.

An anode member 34 is located between the front surface of the cathode member 27 and the phosphor screen 30, being about 2 cm from the cathode member 27, and 2 cm from the screen 30. The anode member 34 is also offset from the axis X-X of the hole 28, being about 2 cm to the right as shown.

When a 1.5 kV potential difference is established between the cathode member 27 and the anode member 34, an electron beam is formed along the axis X-X of the hole, even though the anode member 34 is offset from that axis. The electron beam impinges on the phosphor screen 30 to form a spot.

The intensity of the spot may be varied by modulating the voltage applied to a grid electrode 35, shown in this embodiment to be positioned between the screen 30 and the anode member 34, although it could be located between the anode and cathode members 34 and 27.

A further embodiment of the invention is illustrated schematically in Fig. 17. A cathode member 36 of Kovar has a hole 37 in its front surface and is coated with an electrically insulating layer of glass 38. The cathode member 36 is contained within a glass envelope 39 having on its inner surface a layer of phosphor which acts as a screen 40, and enclosing helium gas at 2 mB pressure. The cathode member 36 is electrically connected via a pin 41, which is also coated in glass 42, forming a stem. In this embodiment a Kovar anode member 43 is located behind the front surface of the cathode member 36 and is positioned co-axially with it about the pin 41.

When in operation a potential difference of 1.5 kV is applied between the cathode and anode members 36 and 43, an electron beam forms along the axis Y-Y of the hole 37 and impinges on the screen 40.

As in the previously described embodiments, a modulating grid may also be included, and/or modulation may be carried out by varying the potential difference applied.

The hole 37 has a diameter of about 5 mm and the front surface of the cathode member 36 may be between a few millimetres and a few centimetres from the screen 40.

Yet another embodiment of the invention is now described with reference to Figs. 18 and

19. A plurality of Kovar strips, only two of which 44 and 45 are shown, are arranged parallel to each other on a glass slab 46. Each of the strips has a plurality of apertures through it, only four of which, 47, 48, 49 and 50; 51, 52, 53 and 54 are shown for each strip. Each strips forms an anode member, electrical signals being applied to them via rods 55 and 56.

10 Cathode members 57 to 64 are of Kovar and have stems extending through the apertures in the strips 44 and 45, there being one cathode member to each aperture, and passing through the glass slab 46. The surfaces of each cathode member, including the connecting pin comprising its stem, are coated in glass layers 65 and 66 except for the side wall and base of the single hole in each ones front surface.

20 The ends of the cathode members 57 to 64 on the side of the glass slab 46 other than the anode strips 44 and 45 are connected via rods 67, 68, 69 and 70, such that one cathode member associated with one strip is electrically connected to a cathode member associated with each of the other strips, giving a crossing relationship between the cathode and anode members. Thus, by applying a potential difference between a suitable cathode member and anode strip, an electron beam may be formed in front of that cathode member.

By placing the structure within an envelope filled with helium at 2 mB pressure, and having a phosphor screen on its inner surface, a display may be produced.

The front surfaces of the cathode members 57 to 64 may be as little as 5 mm from the surface of the screen, and a potential difference between the anode and cathode members of 1.5 kV would be required.

With reference to Fig. 20, a thorated tungsten cathode member 71 has a stem 72 via which electrical connection is made, and is covered with a layer 73 of electrically insulating glass which also extends to the stem 72. An anode member 74 surrounds and is coaxial with the stem 72.

The cathode member 71 has a front surface 75 in which is formed a blind hole 76 of circular cross-section, being 5 mm deep and having a diameter of about 1.5 mm, and having surfaces which are free of the layer 73 of glass. The front surface 73 is inclined with respect to the hole 76 such that the longitudinal axis of the hole 76, shown as broken line 77, is oblique to the normal 78 of the front surface 75 at that point, the angle between them being about 30°.

The cathode and anode arrangement is enclosed within a glass envelope which also contains a gas filling of deuterium at about 2 mB pressure.

In operation, when a suitably high voltage, say 2 kV, is established between the anode

and the cathode members 74 and 71, an electron beam is formed extensive in a direction away from the hole 76 and normal to the front surface 75. If, as illustrated a wall 79, which might be for example the wall of the envelope or some other obstruction, is present, this could restrict the space available to the arrangement. By giving a suitable incline to the front surface 75 the hole 76 can have a depth which might not be possible if its longitudinal axis 77 were arranged to be parallel to the normal 78 to the front surface 75.

With reference to Fig. 21, a thorated tungsten cathode member 80 is connected to stem 81 and is contained within an envelope (not shown) together with a deuterium gas filling at about 2 mB pressure and an anode member 82, which is coaxial with and surrounds the stem 81.

The cathode member 80 and stem 81 are coated with a layer 83 of glass which electrically insulates them from the deuterium gas filling.

A plurality of holes 84 are formed in a front surface 85 of the cathode member 80, each of them being of circular cross-section with a diameter of about 1.5 mm and a depth of 5 mm and having surfaces which are free of the layer 83 of glass. The front surface 85 is curved, for example, it may be parabolically or spherically shaped, rather than the flat surface 75 shown in Fig. 20.

In operation, when a voltage of about 2 kV is applied between the cathode and anode members 80 and 82 a plurality of electron beams are formed extensive normal to the front surface 85 at and in directions away from respective holes, and come to a focus at a point 86 which is located according to the configuration of the front surface 85.

Although the holes 84 are illustrated as being disposed mutually parallel, they could be arranged in some other way, since their attitude does not affect the directions of the electrons beams which are formed during operation.

Apparatus according to the invention in which the surface is curved to produce such focussing might find application in an electron beam welder, for example, in which case the piece being welded may also be for example contained within the envelope. It might also find application in the production of a point source of soft X-rays, having a wavelength of about 6.10^{-10} m, for use in spectroscopy for example, or to generate a point source of incandescent black body radiation.

With reference to Fig. 22, a thyratron in accordance with the invention includes a glass envelope 87, containing a gas filling, an anode 88, a screen grid 89 and control grids 90 and 91, such as might be found in a conventional thyratron. However, instead of the conventionally provided heated cathode, the cath-

ode comprises a cathode member 92 of tungsten having a plurality of holes 93 in its front surface, facing the anode 88. The surface of the cathode member 92 is entirely covered with a glass layer 94 except for the walls and bases of the holes 93. When the thyatron is required to become conducting a suitably high voltage is applied between the anode 88 and the cathode member 92 such that an electron beam is formed extensive in a direction away from each hole. The gas filling becomes ionized and a conduction path is established between the anode 88 and cathode member 92.

Referring to Fig. 23, another thyatron in accordance with the invention includes a glass envelope 95 containing a gas filling, an anode 96, a screen grid 97 and controls grids 98 and 99. It also includes a conventional heated cathode, comprising a hollow cylinder 100 of thermionic material and a heater filament 101.

Two cathode members 102 and 103 are located within the glass envelope 95. Each has a hole 104 and 105 in its front surface and is coated with a glass layer 106 and 107. The longitudinal axes of the holes 104 and 105 are oblique to the front surfaces of the cathode members 102 and 103. The cathode members 102 and 103 also have stem portions 108 and 109 which are surrounded by coaxial anode members 110 and 111 respectively.

During operation of the thyatron, the thermionic material 100 is heated by the heater filament 101 causing electrons to be emitted from its surface. The emitted electrons ionize that part of the gas filling between the controls grids 98 and 99 and the cathode to establish a primary discharge. Then conventionally, to trigger the thyatron, a positive voltage pulse is applied to the control grids 98 and 99, allowing the discharge to penetrate through them to initiate the main discharge, and thus to render the thyatron conducting. However, in addition to this, a voltage may be applied between the cathode members 102 and 103 and the cathode members 110 and 111 respectively, such that electrons beams are formed extensive of the holes 104 and 105 and normal to the front surfaces of the cathode members 102 and 103, their path being shown by broken lines 112 and 113. These beams may be formed simultaneously with, or shortly before or after, the application of the voltage pulse to the control grids 98 and 99. The beams are arranged to pass through apertures in the control grids 98 and 99 and penetrate into the volume beyond them, to ionize the gas filling.

The cathode members could be located elsewhere within the envelope 95 if it is desired to promote ionization in other regions of the thyatron, and of course only one, or

more than two cathode members could be used.

With reference to Fig. 24, another thyatron includes a glass envelope 114, gas filling, an anode 115, a screen grid 116 and control grids 117 and 118. The thyatron includes a thermionic cathode 119 having thermionic material 120 carried by a substrate 121 of high thermal conductivity which may be nickel, for example. A cathode member 122 of tungsten is positioned on the substrate side of the cathode 120. The cathode member 122 has a plurality of holes 123 in its front surface which is concave. The surface of the cathode member 122, except for the walls and bases of holes 123, are covered with a layer 124 of glass. An anode member 125 surrounds the cathode member 122.

In operation, a voltage is applied between the anode member 125 and the cathode member 122 such that a beam of electrons is formed extensive of each hole. The curved surface of the block 122 gives a focussing effect, and the electrons are directed to impinge on the substrate 121, their kinetic energy being converted into heat. Heat is conducted to the thermionic material 120 causing electrons to be emitted to produce ionization of the gas filling.

With reference to Fig. 25, a cathode member is formed by inserting a tungsten cylindrical rod 126 into a hollow tube 127 of an electrically insulating material, such as a ceramic or glass.

Fig. 26 illustrates another cathode member in which a tungsten rod 128 is inserted into a hollow metal tube 129, which may also be of tungsten, and a ceramic tube 130 is fitted over the metal tube 129. Any metal surfaces which would be exposed in use to a gas filling may then be covered with an insulating layer. By employing cathode members of this type no drilling is required, as it is with those previously described.

With reference to Fig. 27, a device in accordance with the invention comprises within an envelope (not shown) which also contains a gas filling, a cylindrical cathode member 131 having a stem portion 132 via which electrical connection is made to the cathode member 131. The cathode member 131 has a front surface 132 of circular transverse cross-section which is of a 'dished' or frusto-conical configuration, the front surface being inclined such that the length of the cathode member 131 along its axis Z-Z increases from its centre to its circumference. Other surface configuration may of course be employed if desired. A hole 133 is located in the centre of the front surface 132 and is coaxial with axis Z-Z of the cathode member 131. The surfaces of the cathode member 131 and the stem portion 132 are covered with a layer 134 of electrically insulating glass, and an anode member 135 surrounds

and is coaxial with the stem portion 132.

When a voltage is applied between the cathode member 131 and the anode member 135 an electron beam is formed extensive of the hole 133. The beam is formed in a direction normal to the front surface 132. Since at the edge of the hole 133 the front surface 132 is inclined, components of the beam at points around the edge of the hole 133 are directed towards the axis Z-Z, such that the beam is brought to a focus F. The position of the focus F depends on the amount of inclination of the front surface. Such a device may thus produce a lens-like action, without the need for electron lens.

If the front surface is flat then a beam is produced which, although it is highly collimated, tends to diverge to some extent because of, for example, scattering processes. By using a front surface having a small degree of dishing, this tendency may be counteracted.

CLAIMS

1. Apparatus for forming an electron beam comprises, within an envelope, an anode member; a cathode member of electrically conductive material; and a gas filling, and wherein, except for part of a front surface of said cathode member, at least substantially the whole of the surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member an electron beam is formed extensive in a direction away from said part of said front surface.

2. Apparatus for forming an electron beam comprising, within an envelope, an anode member; a cathode member of electrically conductive material and having a hole in a front surface thereof; and a gas filling, and wherein, except within said hole, at least substantially the whole of the surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member an electron beam is formed extensive in a direction away from said hole.

3. Apparatus as claimed in claim 2 and wherein the anode member is located in front of the front surface of the cathode member.

4. Apparatus as claimed in claim 3 and including a control grid electrode through which in operation the electron beam passes.

5. Apparatus as claimed in claim 3 or 4 and including a plurality of elongate cathode members arranged in a grid formation, and a plurality of elongate anode members arranged

in a grid formation with said grid of anode members superimposed over said grid of cathode members, but spaced therefrom, with said anode members in crossing relationship with said cathode members to form a matrix, each of said cathode members having a series of holes entering into its surface facing said grid of anode members and each of said anode members having a series of holes passing therethrough, with each hole in an anode member aligned with a hole in a different one of the cathode members, and all surfaces of said cathode members, except for the surfaces within said holes in said cathode members, which would otherwise be exposed to said gas filling are isolated therefrom by electrically insulating material, and the whole arrangement being such that by applying a high potential between one of said anode members and one of said cathode members an electron beam is formed at the crossing point of said last-mentioned two members, said electron beam being extensive in the space between the mouth of the hole in the cathode member at said crossing point and said anode member, said beam being arranged to penetrate through the corresponding hole in said addressed anode member.

6. Apparatus as claimed in claim 5 and wherein insulating material is interposed between said grid of cathode members and said grid of anode members, which insulating material has passages therethrough aligned with said holes in said cathode and anode members whereby to permit communication between one cathode hole and appropriate anode hole but impede communication between that cathode hole and any other anode hole.

7. Apparatus as claimed in claim 6 and wherein said interposed insulating material is provided in the form of a slab having holes extending between its major surfaces and forming the said passages.

8. Apparatus as claimed in claim 5, 6 or 7 and including a control grid electrode located on the inside of the grid of anode members other than that on which the grid of cathode members is located.

9. Apparatus as claimed in claim 5, 6 or 7 and wherein a control grid electrode is located between the grid of cathode members and the grid of anode members.

10. Apparatus as claimed in claim 9 when dependent on claim 6 or 7 and wherein the grid electrode is embedded in the interposed insulating material.

11. Apparatus as claimed in claim 2 and wherein the anode member is located to one side of the axis of the electron beam formed in operation.

12. Apparatus as claimed in claim 2 and wherein the anode member is located behind said front surface of the cathode member.

13. Apparatus as claimed in claim 12 and wherein the anode member is co-axial with

the cathode member.

14. Apparatus as claimed in claim 12 or 13 and including a grid electrode through which in operation the electron beam passes.

5 15. Apparatus as claimed in claim 12, 13, or 14 and wherein there are included a plurality of elongated anode members, each having apertures therein; and a plurality of stemmed cathode members, each having a
10 hole in the front surface thereof and arranged such that its stem extends through one of said apertures, such that each anode member is located behind the front surfaces of cathode members whose stems pass through apertures
15 in said anode member, whereby by applying a high potential between an anode member and one of the cathode members extending through an aperture therein an electron beam is formed extensive in a direction away from
20 the hole in said one of the cathode members.

16. Apparatus as claimed in claim 15 and wherein a cathode member extending through an aperture in one anode member is electrically connected to another cathode member
25 extending through an aperture in another anode member.

17. Apparatus as claimed in claim 16 and wherein a connector connecting two cathode members is spaced from the anode members
30 by electrically insulating material.

18. Apparatus as claimed in any preceding claim and including a phosphor layer arranged so that when an electron beam is formed it impinges upon a spot upon said
35 layer whereby to excite the same.

19. Apparatus as claimed in claim 18 and wherein said envelope has a portion formed as a faceplate on the interior of which said phosphor layer is provided.

40 20. A video signal reproducing apparatus including apparatus as claimed in any preceding claim.

21. Cathode ray tube apparatus comprising a plurality of elongate cathode members
45 arranged in a grid information, a plurality of elongate anode members arranged in a grid formation with said grid of anode members superimposed over said grid of cathode members, but spaced therefrom, with said anode
50 members in crossing relationship with said cathode members to form a matrix, each of said cathode members having a plurality of holes entering into its surface facing said grid of anode members and each of said anode
55 members having a plurality of holes passing therethrough, with each hole in an anode member aligned with a hole in a different one of the cathode members and, superimposed over said grid of anode members on the side
60 thereof remote from said grid of cathode members, a phosphor screen, the two grids being enclosed within an envelope having a gas filling from which all surfaces of said cathode members except for surfaces within
65 said holes in said cathode members, which

would otherwise be exposed to said gas filling are isolated therefrom by electrically insulating material and the whole arrangement being such that by applying a high potential between one of said anode members and one of
70 said cathode members, an electron beam is formed at the crossing point of said last-mentioned two members, said electron beam being extensive in the space between the mouth of the hole in the cathode member at
75 said crossing point and said anode member, said beam penetrating through the corresponding hole in said addressed anode member to impinge upon a spot upon said phosphor screen whereby to excite the same.

22. Apparatus as claimed in claim 2 and wherein the longitudinal axis of said hole is oblique to the normal of said front surface, and the electron beam is formed normal to
85 said front surface at said hole.

23. Apparatus as claimed in claim 22 and including a plurality of holes in said front surface, at least one of said holes having its longitudinal axis oblique to the normal of said
90 surface at the hole, such that upon the application of said suitably high voltage electron beams are formed extensive normal to said front surface at and in a direction away from respective holes.

24. Apparatus as claimed in claim 23 and wherein said front surface is curved.

25. Apparatus for forming electron beams comprising, within an envelope, an anode member; a cathode member of electrically
100 conductive material having a front surface which is curved; and a gas filling, and wherein, except for a plurality of discrete parts of the said front surface, at least substantially the whole of the surface of said cathode
105 member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between
110 said anode member and said cathode member electron beams are formed extensive normal to said front surface at and in a direction away from respective parts.

26. Apparatus as claimed in claim 24 or
115 25 and wherein said front surface is curved such that the electron beams formed are focussed at a point.

27. Apparatus as claimed in claim 22, 23, 24, 25 or 26 and wherein said anode member co-axially surrounds and is behind
120 said front surface of said cathode member.

28. Apparatus as claimed in claim 2 and including a layer of phosphor material on a viewable screen arranged such that upon the
125 application of said suitably high voltage the electron beam impinges upon said phosphor layer and so excites the same.

29. Apparatus as claimed in claim 28 and wherein said anode member has an aperture
130 therein and is located between said cathode

member and said phosphor layer, said electron beam being arranged to penetrate through said aperture.

30. Apparatus as claimed in claim 29 and wherein the hole in said cathode member and said aperture in said anode member are coaxially aligned.

31. Apparatus as claimed in claim 28, 29 or 30 and wherein said envelope has a portion formed as a faceplate upon the inner surface of which said phosphor layer is provided.

32. Apparatus as claimed in any of claims 28 to 31 including a modulating grid provided to affect the strength or intensity of the electron beam impinging upon said phosphor layer.

33. Apparatus as claimed in claim 32 and wherein said modulating grid is a perforated grid or gauze provided between said anode member and said phosphor layer.

34. Apparatus as claimed in claim 32 and wherein said modulating grid or gauze is provided between said anode member and said cathode member.

35. Apparatus as claimed in claim 32 and wherein said modulating grid comprises a ring grid provided within the mouth of said hole in said cathode member.

36. Apparatus as claimed in claim 35 and wherein an electrical connection for said grid is taken out, in insulated fashion, through said cathode member in a direction away from said anode member.

37. Apparatus as claimed in any of claims 28 to 36 wherein electrical connection to said cathode member is provided for by means of a first electrical connector connected to the base of said cathode member.

38. Apparatus as claimed in claim 37 and wherein said first electrical connector is preferably in the form of a hollow cylinder.

39. Apparatus as claimed in claim 38 and wherein, where said modulating grid comprises a ring grid provided within the mouth of said hole in said cathode member and an electrical connection for said grid is taken out, in insulated fashion, through said cathode member in a direction away from said anode member, a second electrical connector for said grid passes through said hollow cylinder.

40. Apparatus as claimed in any of claims 28 to 39 wherein a plurality of holes are provided in said cathode member and a corresponding plurality of holes are provided in said anode member.

41. Display apparatus comprising, within an envelope, a layer of phosphor material on a viewable screen; remote from said phosphor layer, a metallic cathode member having a hole formed in a front surface thereof; between said cathode member and said phosphor layer, an apertured anode electrode; and a gas filling, and wherein, except within said hole at least substantially the whole of the

surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member an electron beam is formed extensive in the space between the mouth of the hole in said cathode member and said anode member, and is arranged to penetrate through an aperture in said anode member to impinge upon said phosphor layer and so excite the same.

42. Thyatron apparatus comprising, within an envelope, an anode member; a cathode member of electrically conductive material and having a hole in a front surface thereof; and a gas filling, and wherein, except within said hole, at least substantially the whole of the surface of said cathode member which would otherwise be exposed to the gas filling within said envelope is covered with an electrically insulating material, the whole arrangement being such that upon the application of a suitably high voltage between said anode member and said cathode member an electron beam is formed extensive in a direction away from said hole.

43. Apparatus as claimed in claim 42 and wherein said cathode member has a plurality of holes in the front surface thereof, such that upon application of a suitably high voltage electron beams are formed extensive in a direction away from respective holes.

44. Apparatus as claimed in claim 43 and wherein said front surface is curved.

45. Apparatus as claimed in claim 44 and wherein at least one of said holes has its longitudinal axis oblique to the normal of said front surface at that hole.

46. Apparatus as claimed in any of claims 42 to 45 and including thermionic material arranged such that when an electron beam, or beams are formed they heat the same.

46. Apparatus as claimed in claim 42 and wherein, when said electron beam is formed it is arranged to ionize the gas filling in a localised region.

48. Apparatus as claimed in claim 47 and wherein the longitudinal axis of said hole is oblique to the normal of said front surface at the hole.

49. Apparatus as claimed in claim 2 and wherein said front surface is shaped to focus said electron beam.

50. Apparatus as claimed in claim 2 or 49 and wherein said front surface is substantially frusto-conical, the hole being centrally located.

51. Apparatus as claimed in any of claims 2 to 50 and wherein the or each hole in a cathode member is blind.

52. Apparatus as claimed in any of claims 2 to 51 and wherein the or each hole in a cathode member is of circular cross-section.

53. Apparatus as claimed in any of claims 2 to 52 and wherein the side wall and base surfaces of the or each hole in a cathode member is entirely free of a covering of electrically insulating material.

54. Apparatus as claimed in any preceding claim and wherein said insulating material insulating surfaces of said cathode member or plurality of cathode members from said gas filling is glass.

55. Apparatus as claimed in any preceding claim and wherein said cathode member, or plurality of cathode members, is of Kovar.

56. Apparatus as claimed in any preceding claim and where said anode member, or plurality of anode members, is of Kovar.

57. Apparatus as claimed in any preceding claim, and wherein said envelope is of glass.

58. Apparatus as claimed in any preceding claim and wherein the said gas filling is helium.

59. Apparatus as claimed in any preceding claim and wherein said gas filling is at a pressure of between 0.5 and 2.5 mB.

60. Apparatus as claimed in any preceding claim and wherein the high voltage applied between the anode member and the cathode member is between 1 and 2.5 kV.

61. Apparatus as claimed in any preceding claim and wherein said cathode member is of thorated tungsten.

62. Apparatus substantially as illustrated in and described with reference to Fig. 1 of the accompanying drawings.

63. Apparatus substantially as illustrated in and described with reference to Fig. 2 of the accompanying drawings.

64. Apparatus substantially as illustrated in and described with reference to Fig. 3 of the accompanying drawings.

65. Apparatus substantially as illustrated in and described with reference to Fig. 6 of the accompanying drawings.

66. Apparatus substantially as illustrated in and described with reference to Figs. 7 to 12 of the accompanying drawings.

67. Apparatus substantially as illustrated in and described with reference to Figs. 13 to 15 of the accompanying drawings.

68. Apparatus substantially as illustrated in and described with reference to Fig. 16 of the accompanying drawings.

69. Apparatus substantially as illustrated in and described with reference to Fig. 17 of the accompanying drawings.

70. Apparatus substantially as illustrated in and described with reference to Figs. 18 and 19 of the accompanying drawings.

71. Apparatus substantially as illustrated in and described with reference to Fig. 20 of the accompanying drawings.

72. Apparatus substantially as illustrated in and described with reference to Fig. 21 of the accompanying drawings.

73. Apparatus substantially as illustrated in and described with reference to Fig. 22 of the accompanying drawings.

74. Apparatus substantially as illustrated in and described with reference to Fig. 23 of the accompanying drawings.

75. Apparatus substantially as illustrated in and described with reference to Figs. 24 of the accompanying drawings.

76. Apparatus substantially as illustrated in and described with reference to Fig. 25 of the accompanying drawings.

77. Apparatus substantially as illustrated in and described with reference to Fig. 26 of the accompanying drawings.

78. Apparatus substantially as illustrated in and described with reference to Fig. 27 of the accompanying drawings.

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